

Title (en)

NANOELECTRODE DEVICES AND METHODS OF FABRICATION THEREOF

Title (de)

NANOELEKTRODENVORRICHTUNGEN UND VERFAHREN ZUR HERSTELLUNG DAVON

Title (fr)

DISPOSITIFS À NANOÉLECTRODES ET PROCÉDÉS DE FABRICATION ASSOCIÉS

Publication

**EP 3688449 A1 20200805 (EN)**

Application

**EP 18861291 A 20180927**

Priority

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Abstract (en)

[origin: WO2019065904A1] The present disclosure provides devices and methods for fabrication of nanoelectrode pairs which may be useful for use with tunneling labels. Devices fabricated as described may have good spacing tolerances, angular tolerances, surface uniformity, and may have reduced particulate contamination.

IPC 8 full level

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